

Notice of References Cited		Application/Control No. 10/573,985	Applicant(s)/Patent Under Reexamination MURAMATSU ET AL.	
		Examiner Kim-Kwok CHU	Art Unit 2627	Page 1 of 1

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*		Document Number Country Code-Number-Kind Code	Date MM-YYYY	Name	Classification
*	A	US-7,218,585	05-2007	Tanii et al.	369/47.36
*	B	US-7,184,377	02-2007	Ito et al.	369/47.14
*	C	US-7,113,475	09-2006	Lee et al.	369/275.3
*	D	US-5,966,721	10-1999	Hirayama et al.	711/4
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	J	US-			
	K	US-			
	L	US-			
	M	US-			

FOREIGN PATENT DOCUMENTS

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NON-PATENT DOCUMENTS

*		Include as applicable: Author, Title Date, Publisher, Edition or Volume, Pertinent Pages)
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*A copy of this reference is not being furnished with this Office action. (See MPEP § 707.05(a).)
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